

# INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)

WFS.004C

Application Number 10/673,569

NEW

Applicant(s)

Daniel R. Neal et al.

Filing Date

30 September 2003

Group Art Unit

FBA 1756

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
10/AD	A	3,808,035	04-1974	Stelter, Manfred K.	427	74	
	B	4,327,129	04-1982	Sepp, Gunther	427	164	
	C	5,186,975	02-1993	Tizabi et al.	427	99	
	D	5,460,908	10-1996	Reinberg, Alan R.	430	5	
	E	5,534,312	07-1996	Hill et al.	427	533	
	F	5,972,794	10-1999	Katakura, Norihiro	438	704	
	G	5,691,116	11-1997	Revelli et al.	430	321	
	H	5,853,960	12-1998	Tran et al.	430	321	
✓	I	5,367,588	11-1994	Hill et al.	385	37	
10/AD	J	5,814,803	09-1998	Olmstead et al.	235	462.01	

## FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
K	1,298,724	8-13-1987	Canada				

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

L	Snezhko, L.I., "On the accuracy of the Hartmann method for testing aspherical wavefronts," pp. 505-508, Soviet Journal of Optical Technology, Vol. 47, No. 9, September 1980.

EXAMINER

K. Duda

DATE CONSIDERED

7-20-04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.